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PTO-1449 MAY 2 5 2005 Information Disclosure Sitation			Application No.	Applicant(s)	Applicant(s) David S. Kelman				
			10749,137	David S. Kel					
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EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.